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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :  
Kouji IWASAKI :  
Serial No. 10/712,147 : Group Art Unit - 1742  
Filed: November 13, 2003 : Examiner - Scott R. Kastler  
For: METHOD AND SYSTEM FOR :  
FABRICATING THREE- :  
DIMENSIONAL MICRO- :  
STRUCTURE : Docket No. S005-5148

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Mail Stop AMENDMENT  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

**RESPONSE**

S I R:

In response to the Office Action dated June 13,  
2006, applicant amends his application as follows:

**ELECTION OF INVENTION:**

Applicant provisionally elects, with traverse, the  
invention characterized by the Examiner as Group I drawn to a  
method of fabricating a three dimensional microstructure and  
submit that claims 1-6 and 9-15 are readable on the elected  
invention.

**MAILING CERTIFICATE ON PAGE 3**